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By:

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(Attorney Signature and Reg. No.)

50,991

Patent
Attorney's Docket No. 10015155-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Laurie S. Mittelstadt et al.

Application No.: 10/091,485

Filed: March 7, 2002

For: ION EXCHANGE SYSTEM

STRUCTURE WITH A

MICROTEXTURED SURFACE,

METHOD OF MANUFACTURE,

AND METHOD OF USE THEREOF

) Mail Stop AF

) Group Art Unit: 1745

) Examiner: Yuan, Dah Wei D

) Confirmation No.: 9468

AMENDMENT PURSUANT TO 37 C.F.R. §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action mailed May 28, 2004, please amend the above-identified patent application as follows: